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E.R.Wutt  
Attorney for Applicants

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Appl. No.	:	10/614,465	Confirmation No.: 7607
Applicant	:	Tehsin Lee et al.	
Title	:	METHOD AND SYSTEM FOR POST-TREATING DRY-ETCHED METAL FILM	
Filed	:	July 7, 2003	
TC/A.U.	:	1763	
Examiner	:	Roberts P. Culbert	
Docket No.	:	3304.2.66	
Customer No.	:	21552	

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

AMENDMENT AND RESPONSE TO OFFICE ACTION

Dear Sir:

This paper is filed in response to the Office Action of March 24, 2005. A Petition for Extension of Time, one month, is filed to extend the response deadline until July 24, 2005. Please amend the above-identified application as follows:

**Amendments to the Specification** begin on page 2 of this paper.

**Amendments to the Claims** are reflected in the listing of claims which begins on page 5 of this paper.

**Remarks/Arguments** begin on page 6 of this paper.